

# **Improvement of Silicon-Based Neutron Spectrometry**

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# Outline

- Motivation
- The low-energy limit of the neutron spectrometer
- The coincidence detector for the  $\gamma$ -field discrimination
- Electron vs. proton identification and discrimination
- Results
- Conclusions

# Motivation

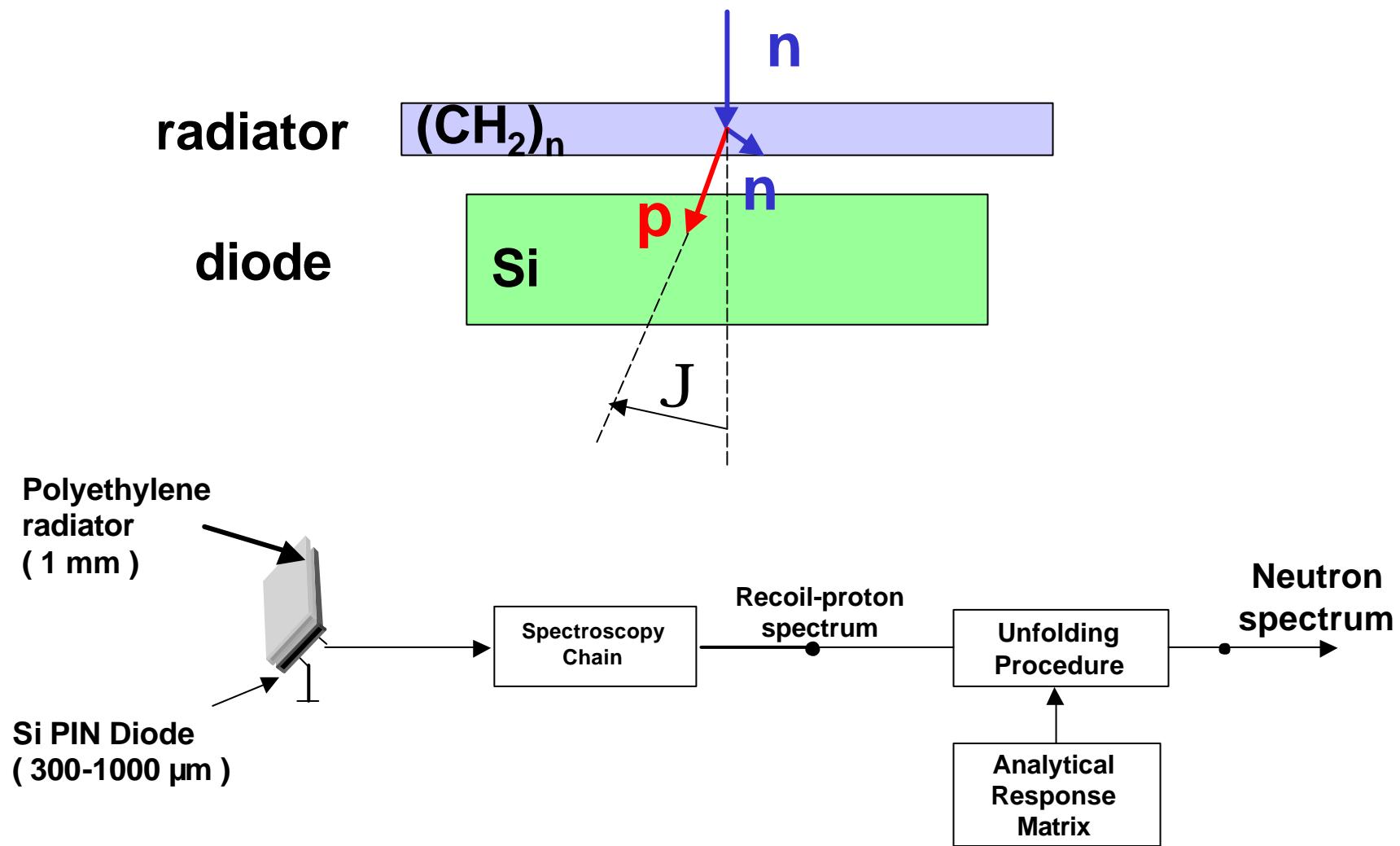
Development of a **neutron spectrometer**  
for the characterization of neutron fields  
in the range **100 keV - 10 MeV**

with fluence rate  **$10^4\text{--}10^6 \text{ cm}^{-2} \text{ s}^{-1}$**   
(e.g. generated by low-energy ion accelerators)

based on **silicon diodes**  
good **spatial and energy resolution**

- Biological cultures irradiations
- Electronic circuit radiation damage studies
- Shielding calculation for radiation protection

# Recoil-proton neutron spectrometer



# Distribution of the recoil proton energy $p(E_p)$

The collision between n and p in the center of mass reference system is **isotropic** and **elastic** in the MeV energy range

In the laboratory system  $\theta$  is the angle between the incoming n and the recoil p:

$$V_p = V_{in} \cos \theta, \quad E_p = E_{in} \cos^2 \theta \quad \text{and differentiating } dE_p = -E_{in} 2 \cos \theta \sin \theta d\theta.$$

Integrating the differential cross section (Lab) in the solid angle between  $\theta$  and  $\theta+d\theta$

$$p(\theta) d\theta = 2 \cos \theta \sin \theta d\theta \quad \text{maximum for } \theta = \pi/4$$

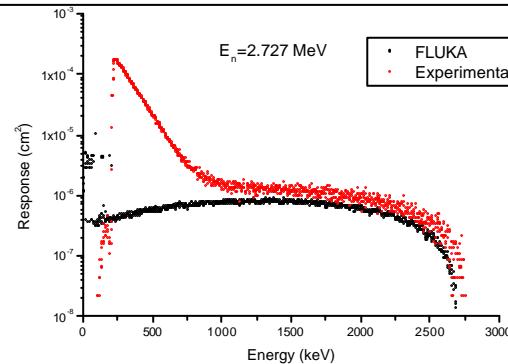
$$p(E_p) dE_p = p(\theta) d\theta$$

Substituting there is a cancellation and

$$p(E_p) = 1/E_n \quad \text{with } 0 < E_p < E_n$$

**CONSTANT**

From 2003 Seminar



# Distribution of the deposited energy by recoil protons in silicon $p(E_d)$

Model equations:

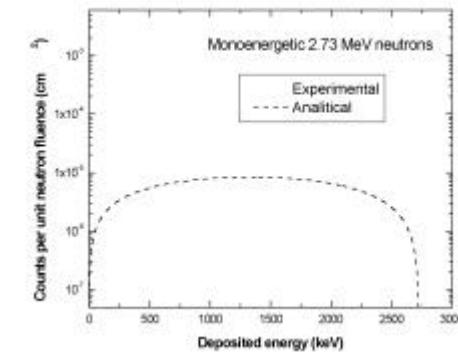
$$p(E_p) = 1/E_n \quad \text{in the interval } (0 - E_n)$$

$$R_p = R_0 \cdot E_p^\beta \quad \text{range-energy power law}$$

$$R_{\text{total}} = R_{\text{radiator}} + R_{\text{detector}} \quad (\text{no dead layer})$$

$$E_d = [(E_n \cdot \cos^2 \theta)^\beta - h / (R_0 \cdot \cos \theta)]^{1/\beta}$$

$$p(E_d) = 2/3 \cdot \beta \cdot (E_d / E_n)^{\beta-1} / E_n \cdot [1 - (E_d / E_n)^{3/2}]$$



# Recoil-proton neutron spectrometer efficiency

Efficiency [cm<sup>2</sup>] = count rate [count s<sup>-1</sup>] / fluence rate [neutrons s<sup>-1</sup> cm<sup>-2</sup>]

$$\sigma = 3.675 \text{ barn} \quad @ 1.3 \text{ MeV } (\sim E^{-1/2})$$

$$\Sigma_{\text{polyethylene}} = \sigma n_H = 0.3 \text{ cm}^{-1}$$

$$t = R_{p,p} = 35 \mu\text{m} \quad @ 1.3 \text{ MeV } (\sim E^{\beta}) \text{ thickness of int vol}$$

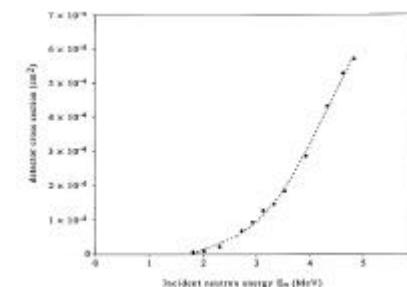
$$N_{r-p} / N_n \sim \Sigma t \sim 10^{-3} \quad @ 1.3 \text{ MeV} \quad r-p \text{ ejected}$$

Rec-prot auto-absorption ~ 1/3

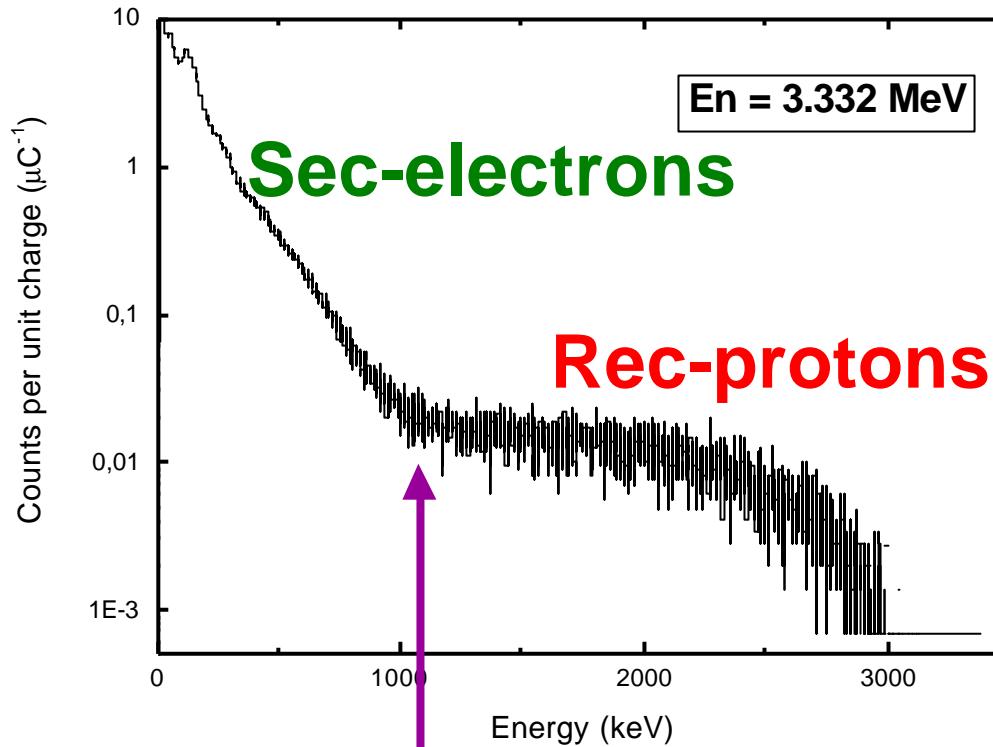
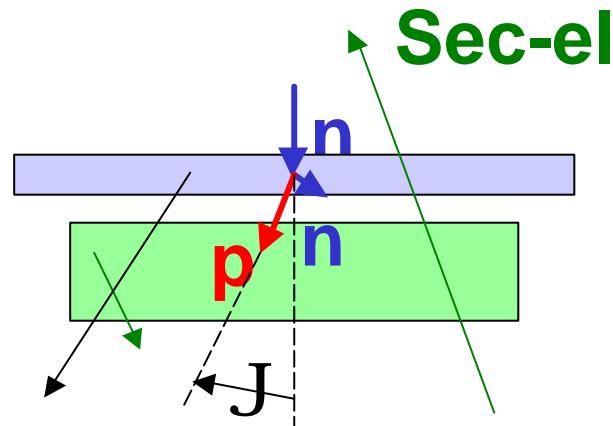
$$\text{Efficiency [cm}^2\text{] / Area [cm}^2\text{]} \sim 1/3 (N_{r-p} / N_n) \sim 3 \cdot 10^{-4} \quad (\sim E^{1.78-0.5})$$

$$A = 1 \text{ mm}^2, \nu = 1 \text{ cps} \quad fr = 3 \cdot 10^{-5} \text{ s}^{-1} \text{ cm}^{-2}$$

$$A = 10 \text{ mm}^2, \nu = 1 \text{ cps} \quad fr = 3 \cdot 10^{-4} \text{ s}^{-1} \text{ cm}^{-2}$$



# Low-energy limit of the response function

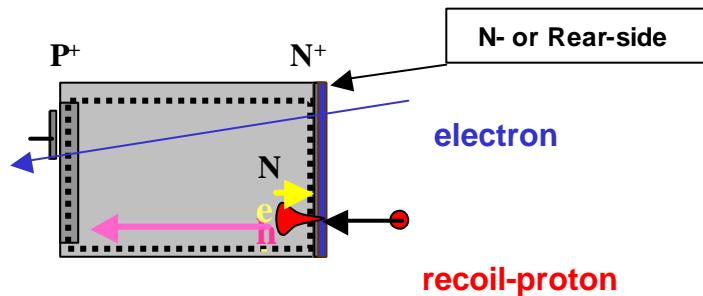


**Low energy limit**

# Pulse Shape Discrimination with silicon p-i-n diode

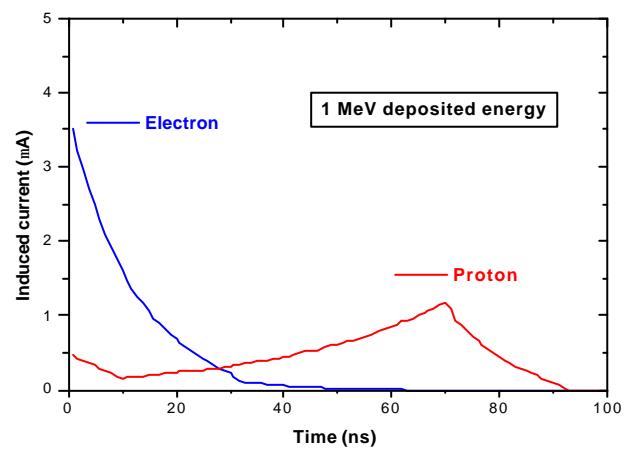
A. Fazzi et al. 2003 IEEE NSS

“Rear-side injection”

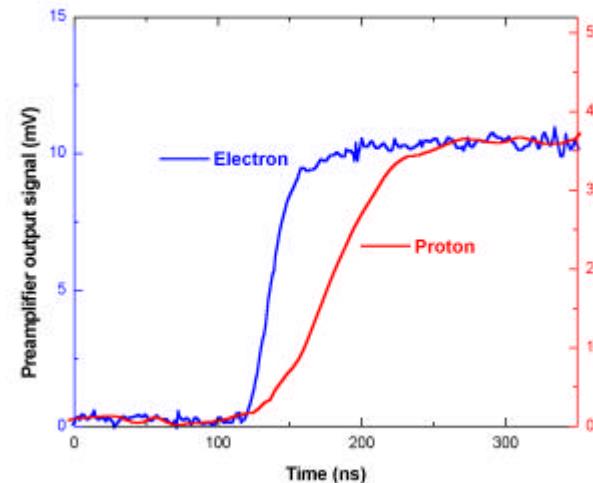


FZ High Res Silicon  
300  $\mu\text{m}$  thick  
3 mm<sup>2</sup> area

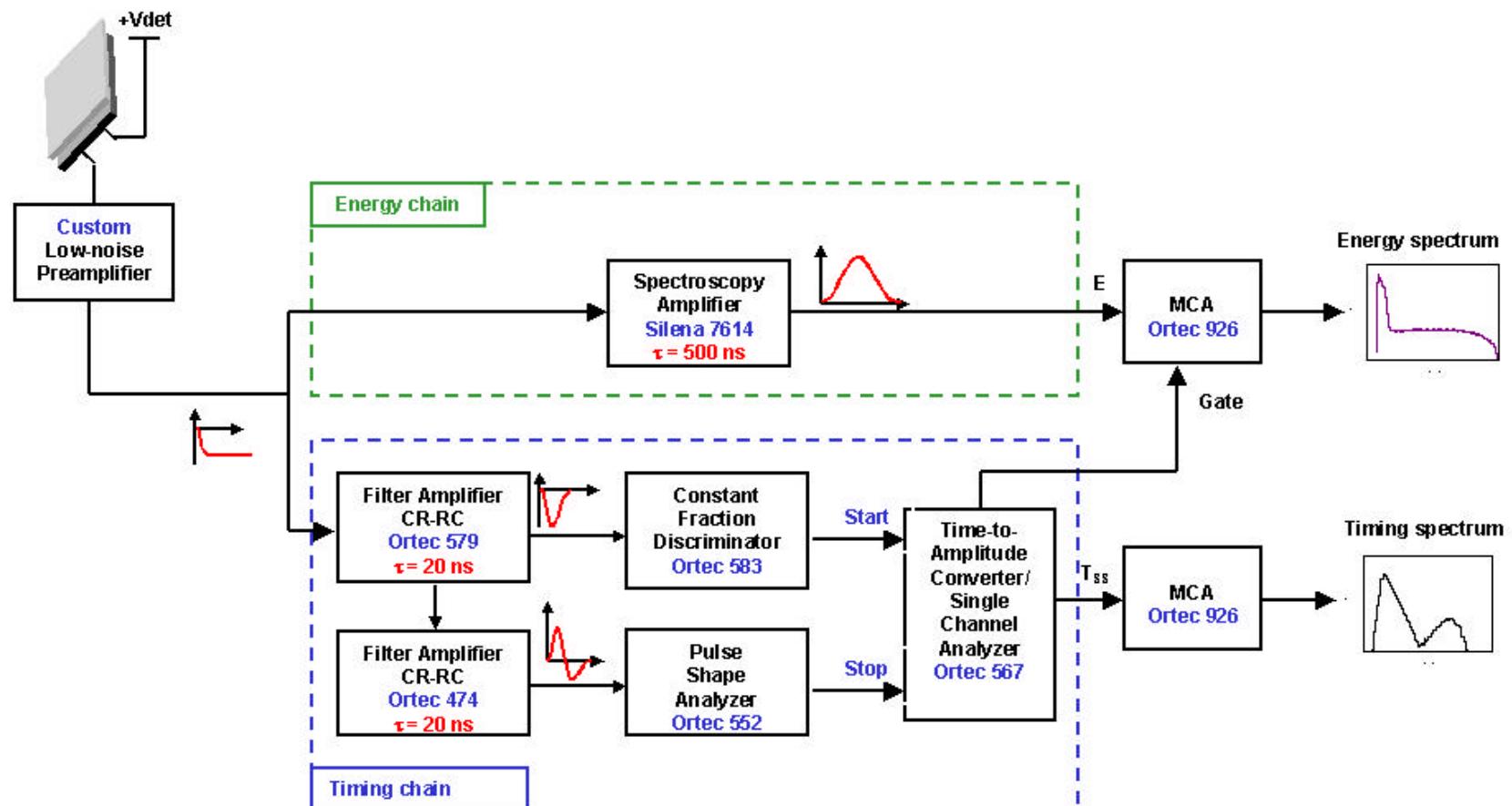
simulation



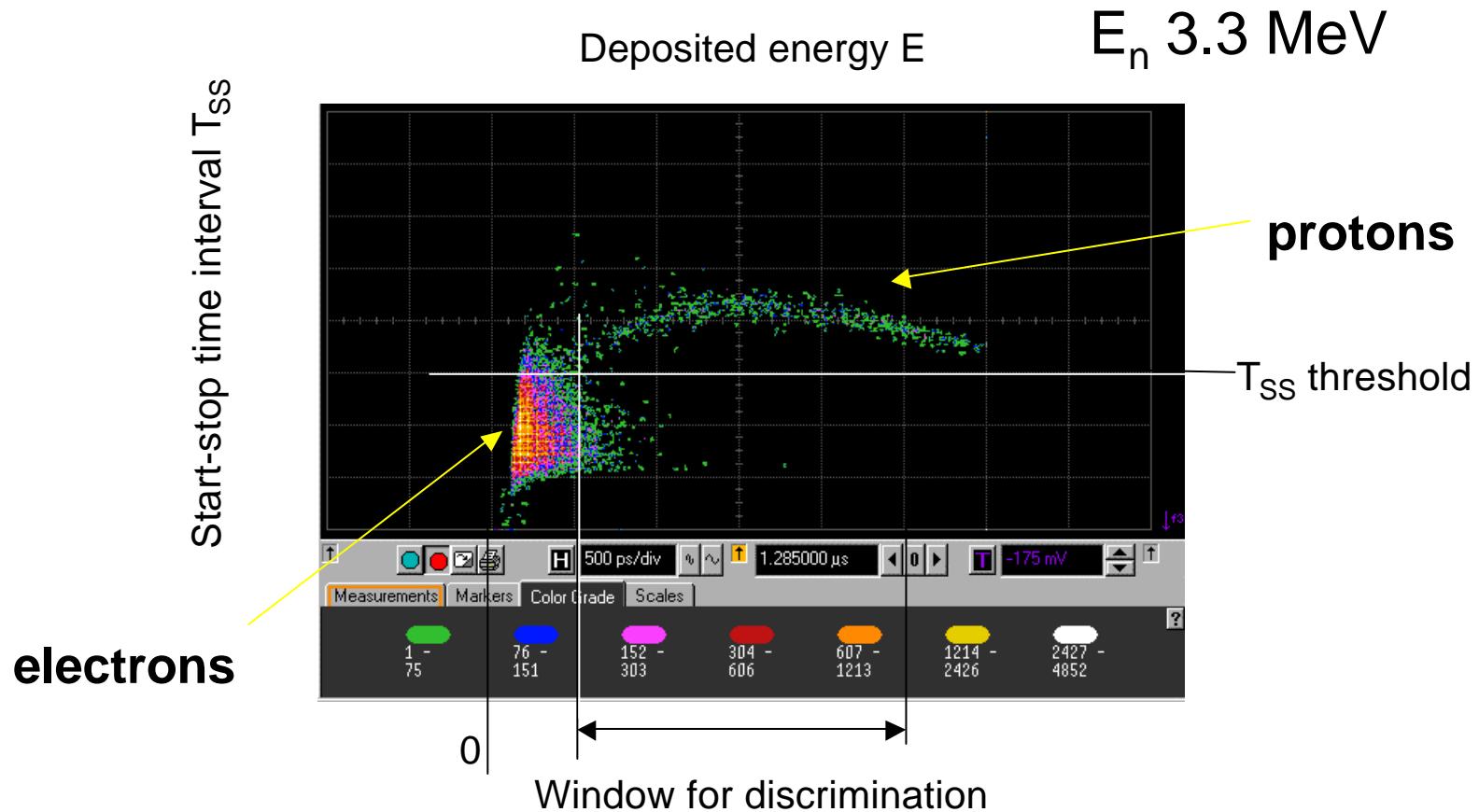
experimental



# Electronics for pulse shape analysis

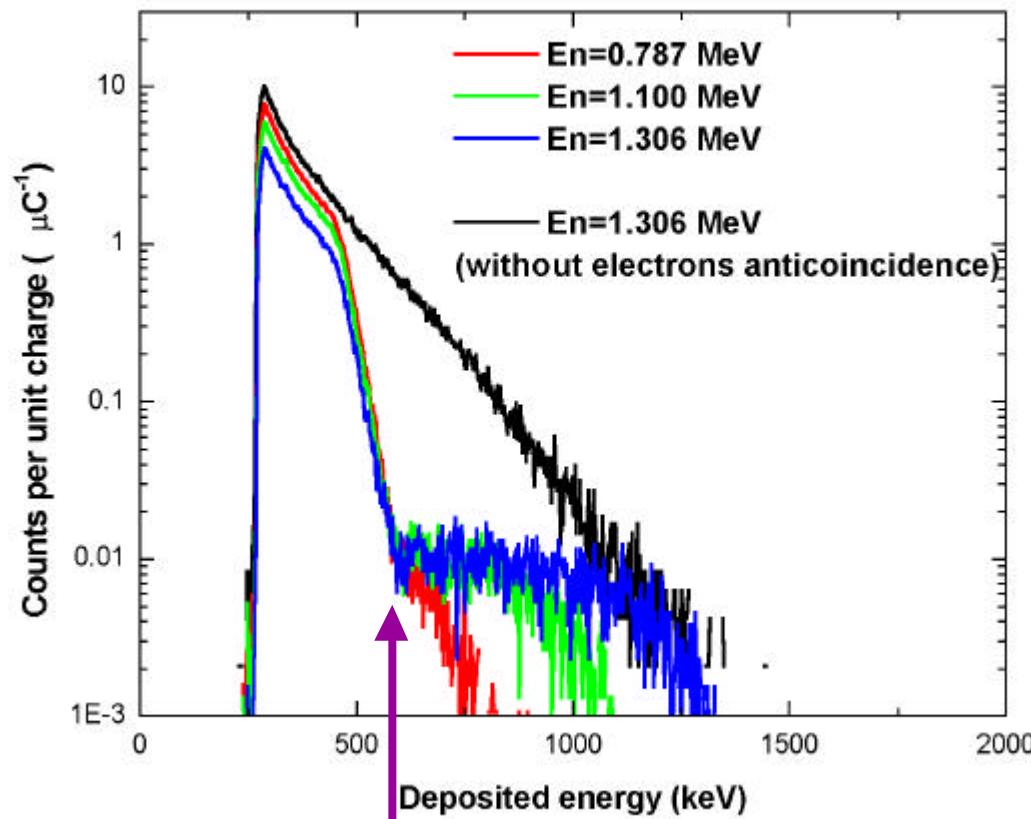


# Energy-time scatter plot for monoenergetic neutrons



# Pulse shape discrimination of secondary-electrons

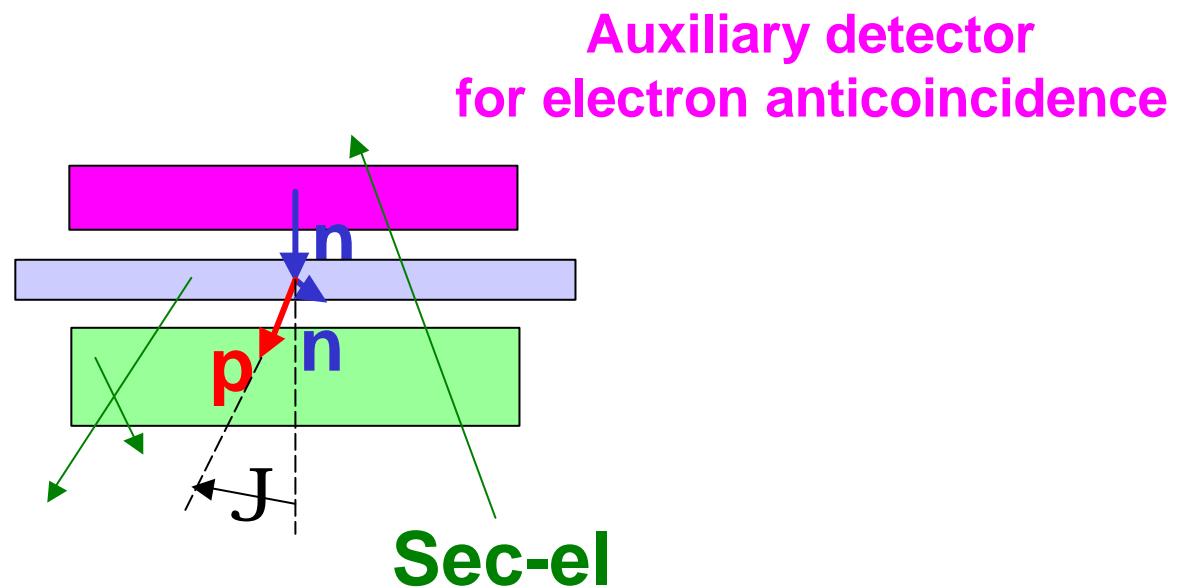
## Response functions for “low-energy” neutrons



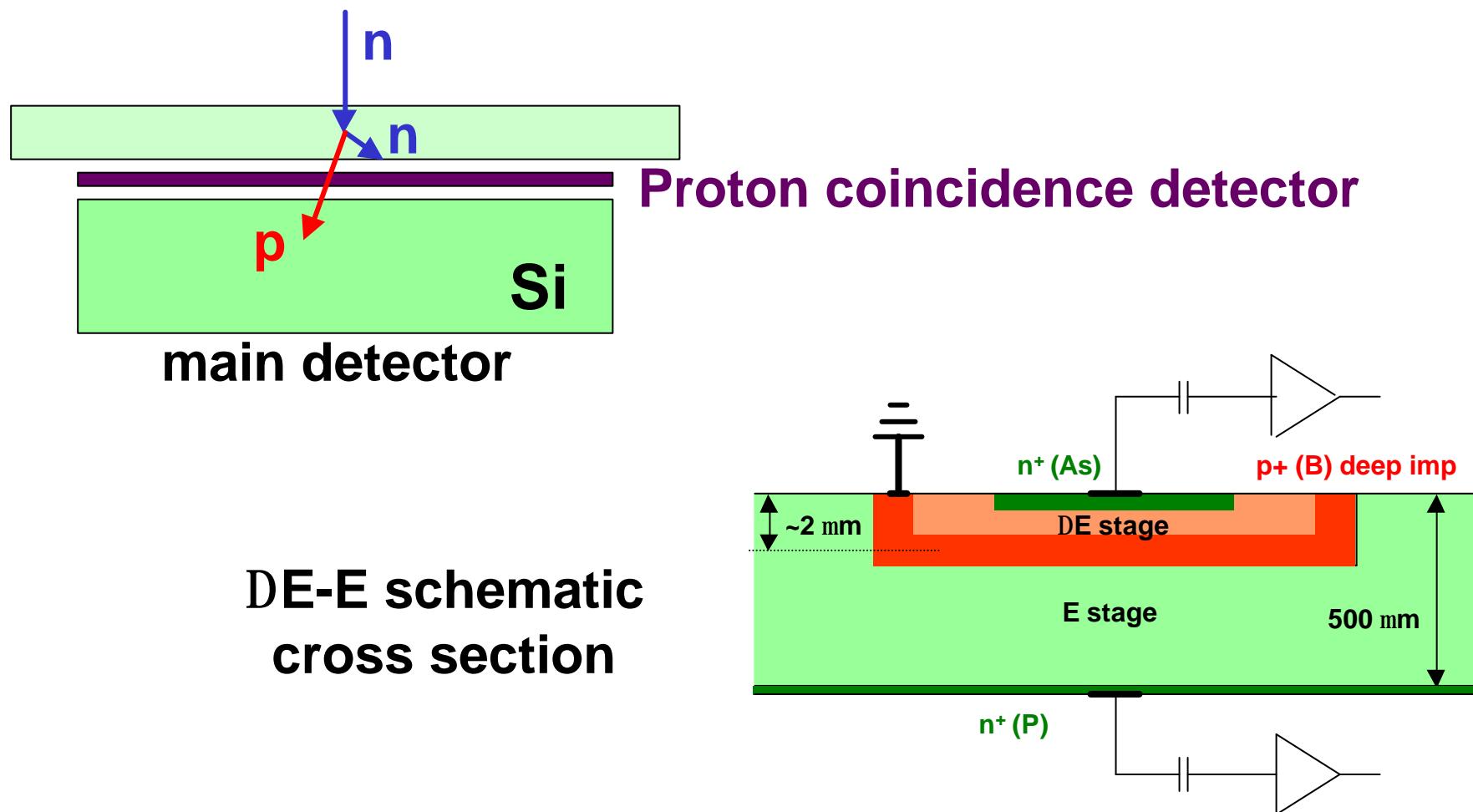
**Low-energy limit ~ 600 keV**

A. Fazzi et al., 2003 IEEE NSS

# Bo Yu suggestion after 2003 seminar

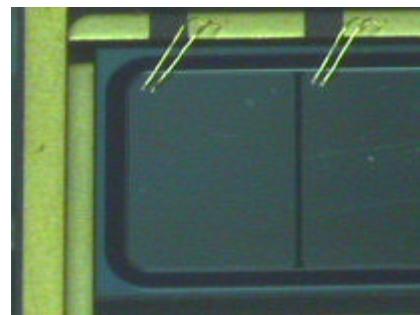
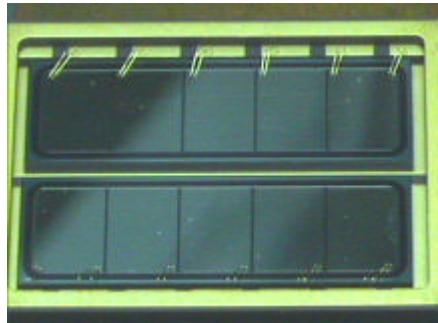


# Thin monolithic coincidence detector



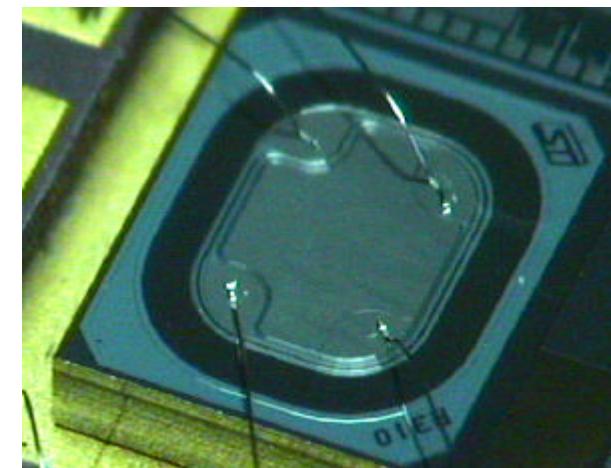
G. Cardella et al., NIM A 378 (1996)

# The DE-E monolithic silicon telescope

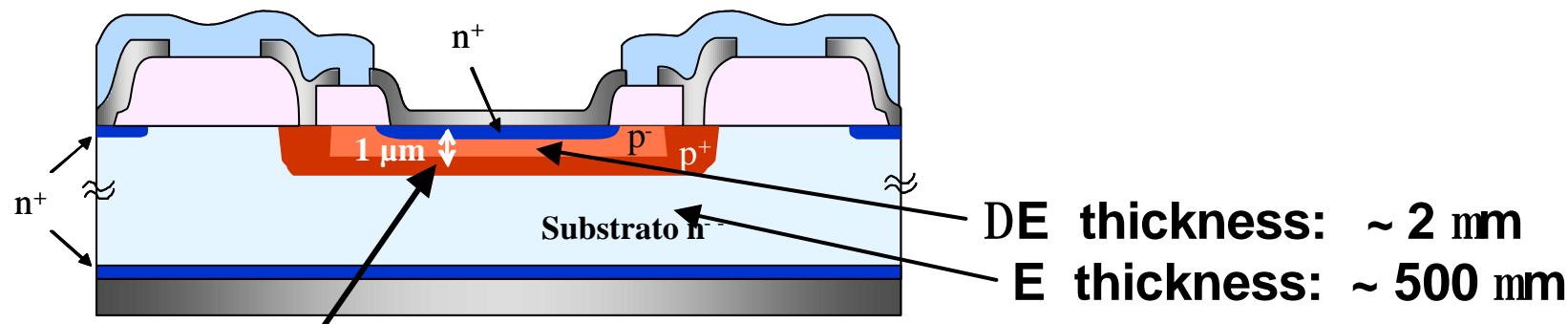


10 mm<sup>2</sup>

Detailed cross section of DE-E (STM)



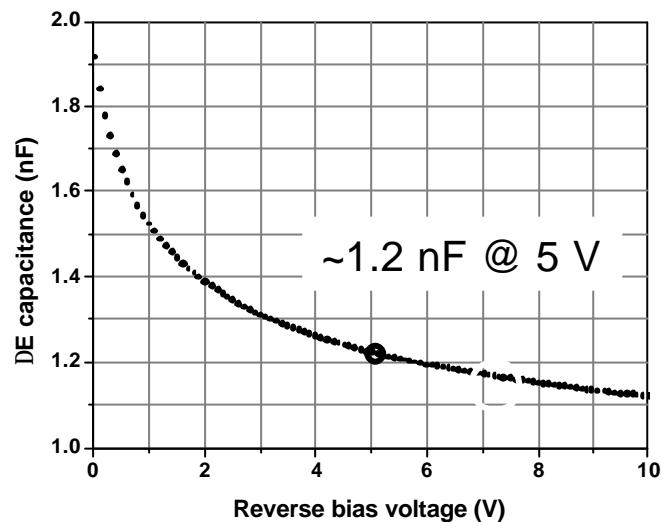
Active area: ~ 1 mm<sup>2</sup>



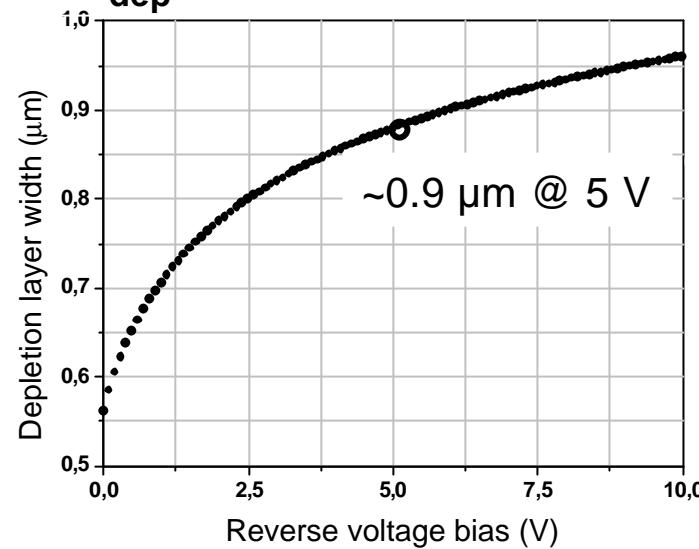
The p<sup>+</sup> cathode acts as a “watershed” for the charge collection

# DE-E electrical characterization (10 mm<sup>2</sup>)

**C - V curve**



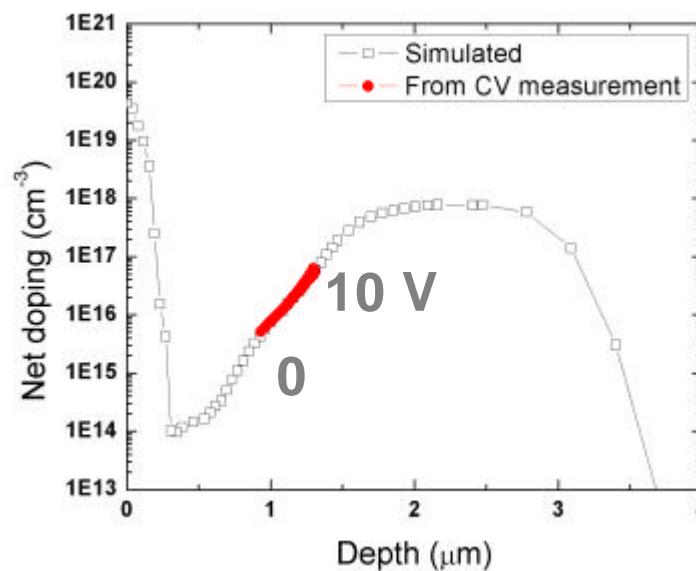
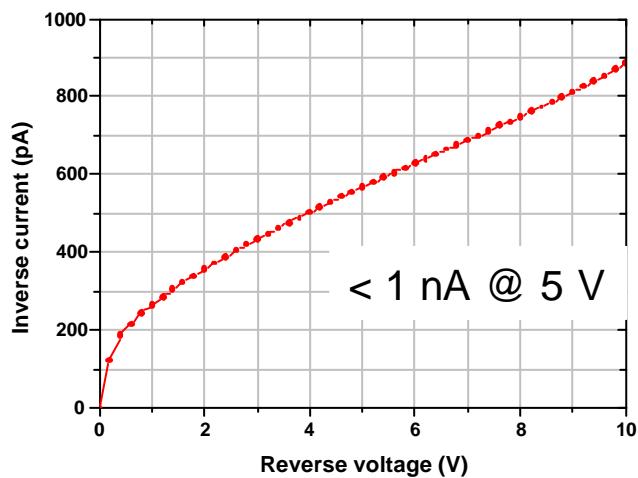
**X<sub>dep</sub> – V characteristic**



$$C^0 = 0.12 \text{ nF}\cdot\text{mm}^{-2}$$

$$J_L = 0.1 \text{ nA}\cdot\text{mm}^{-2}$$

**Reverse I - V curve**



**DE**

$$A = 1 \text{ mm}^2$$

$$C = 165 \text{ pF}$$

$$I_L = 135 \text{ pA}$$

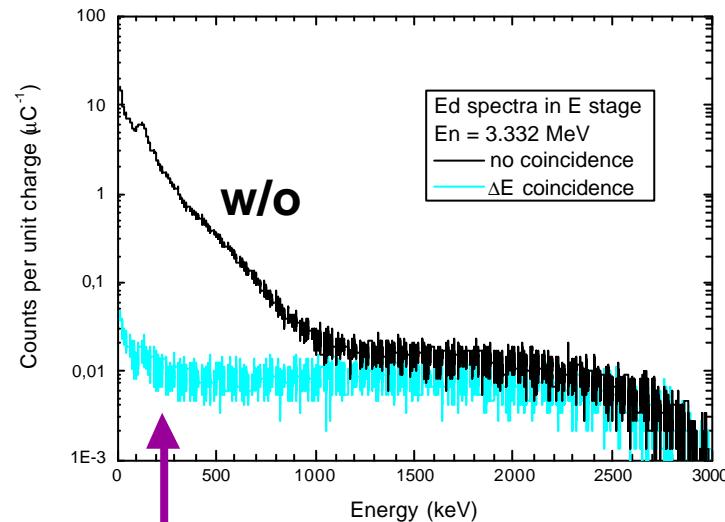
**E**

$$C = 6 \text{ pF}$$

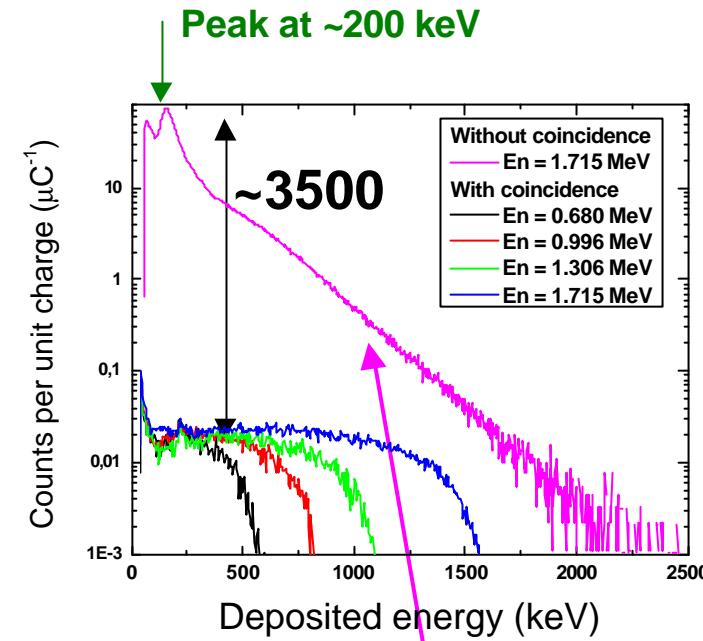
$$I_L = 500 \text{ pA}$$

# DE-coincidence response functions

## Strong g-field rejection



Low-energy limit ?

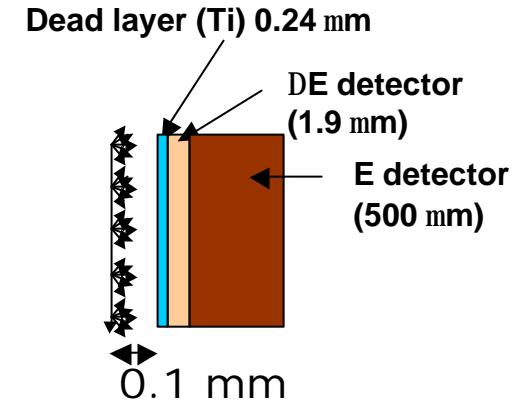


w/o DE  
coincidence

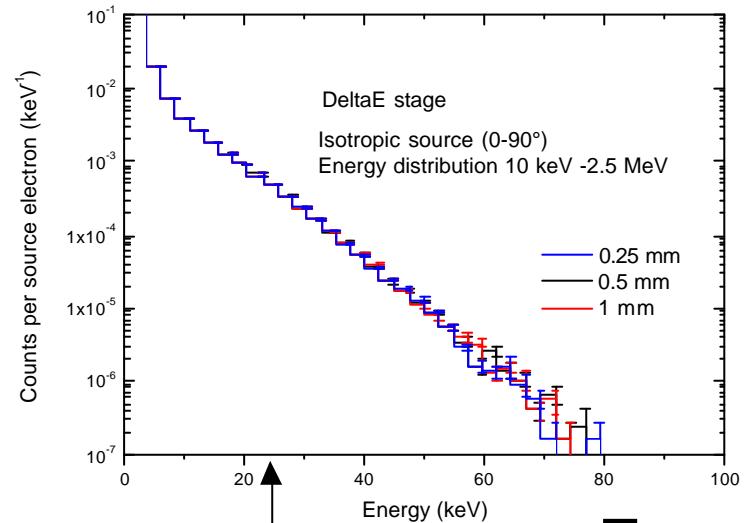
Complete sec-electron discrimination ?

# MC simulation of the secondary electrons

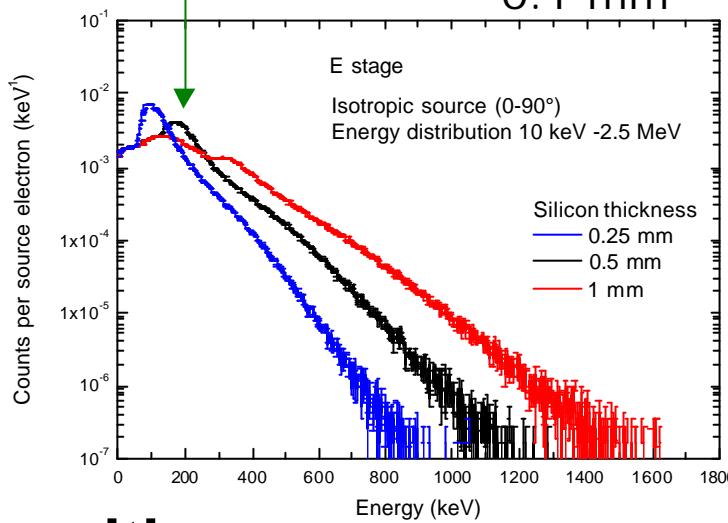
**Homogeneous source of electrons  
constant distribution 10 keV - 2.5 MeV**



## DE stage



**Peak at ~200 keV**



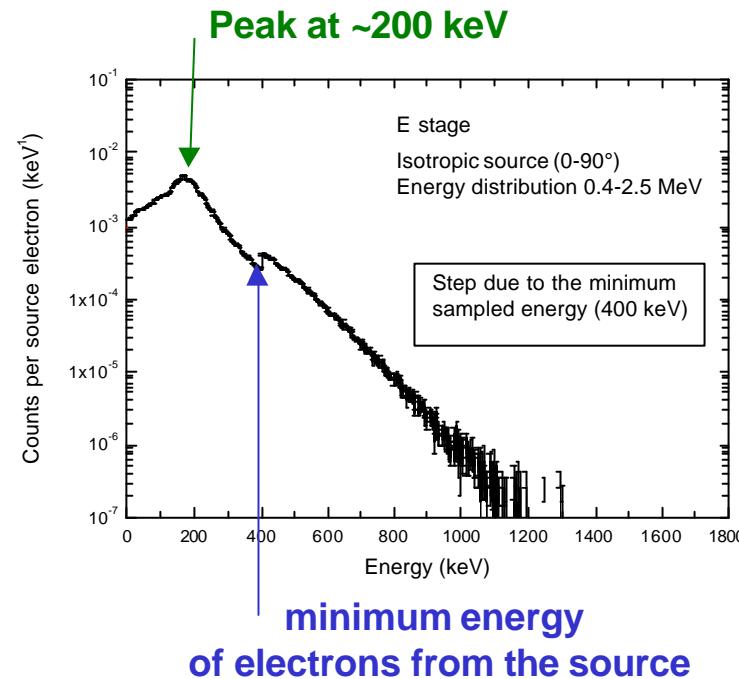
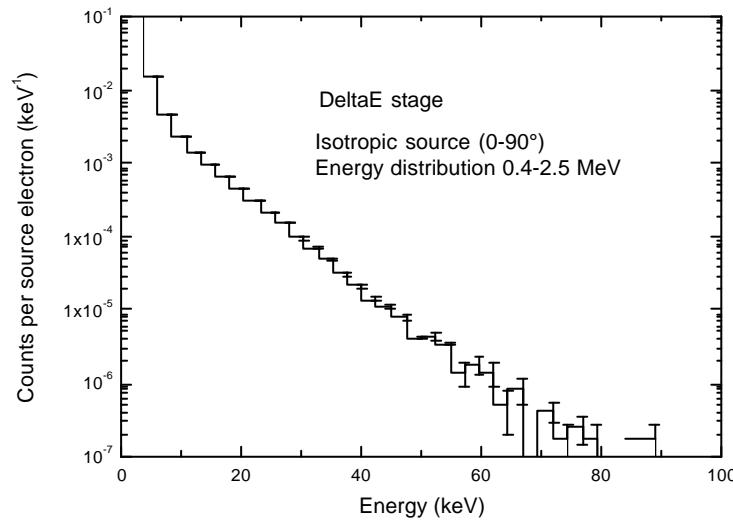
## Energy deposition

## E stage

**Also sec-el are triggered in DE-coincidence !**

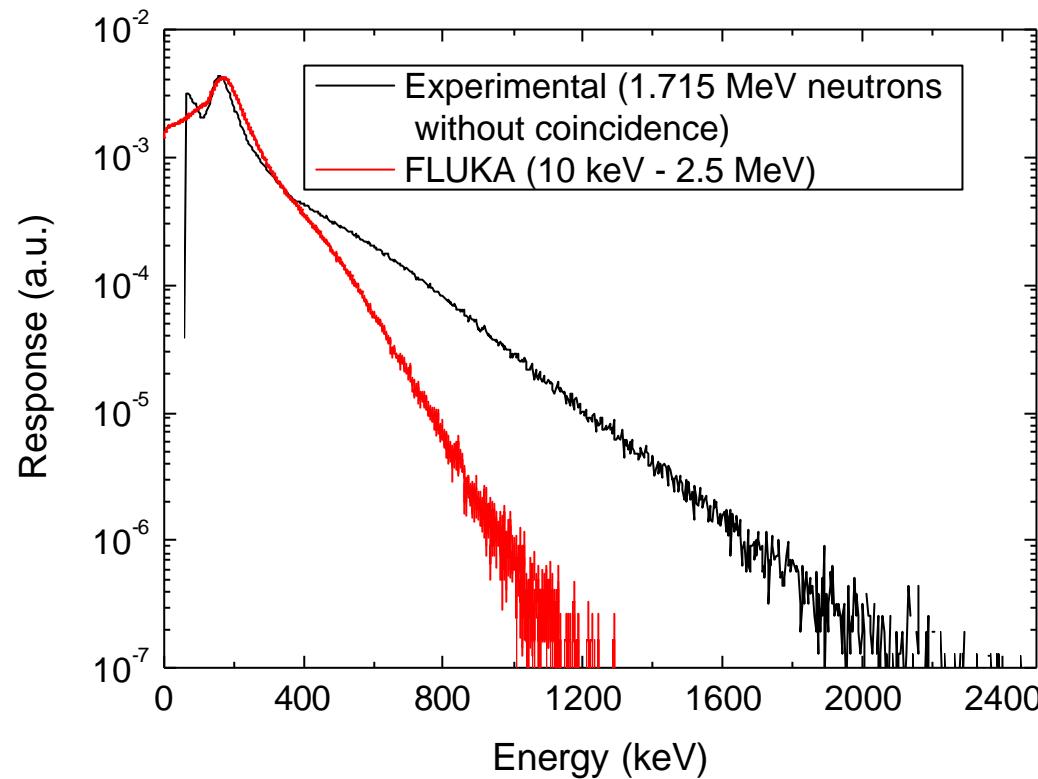
# MC simulation of the secondary electrons 2

Homogeneous source of electrons  
constant distribution **400 keV - 2.5 MeV**

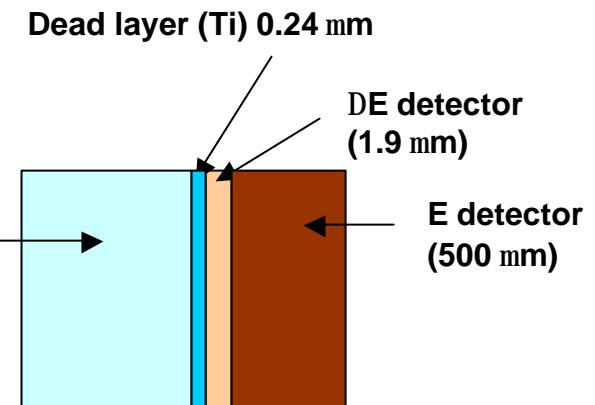
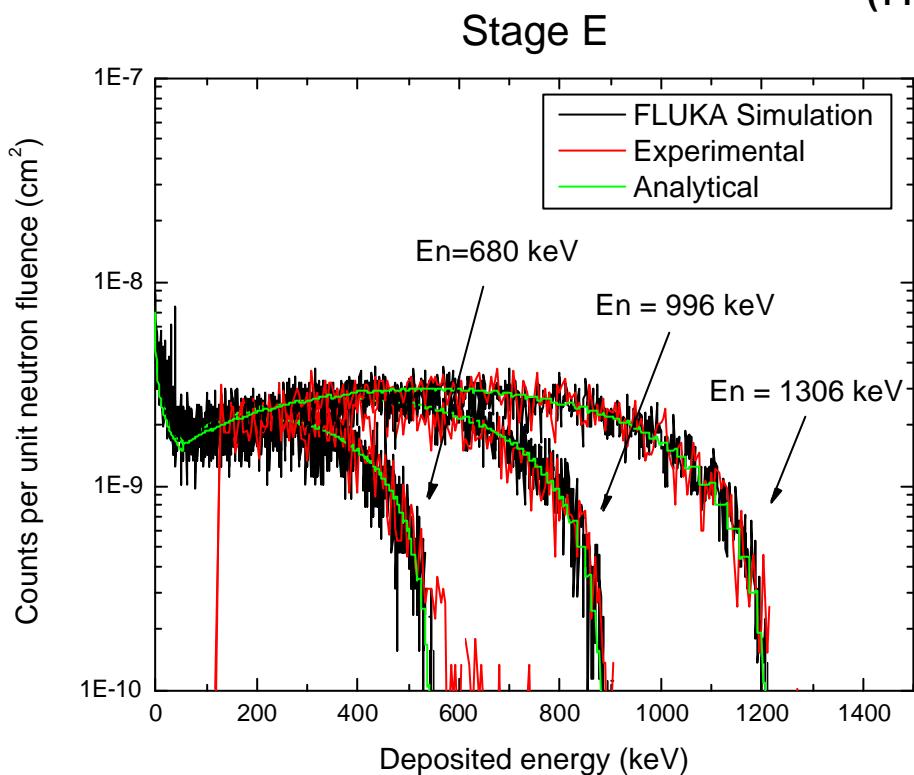


# **Response to electrons: experimental vs. simulated**

**Pile-up rate: @ 8 s<sup>-1</sup>**



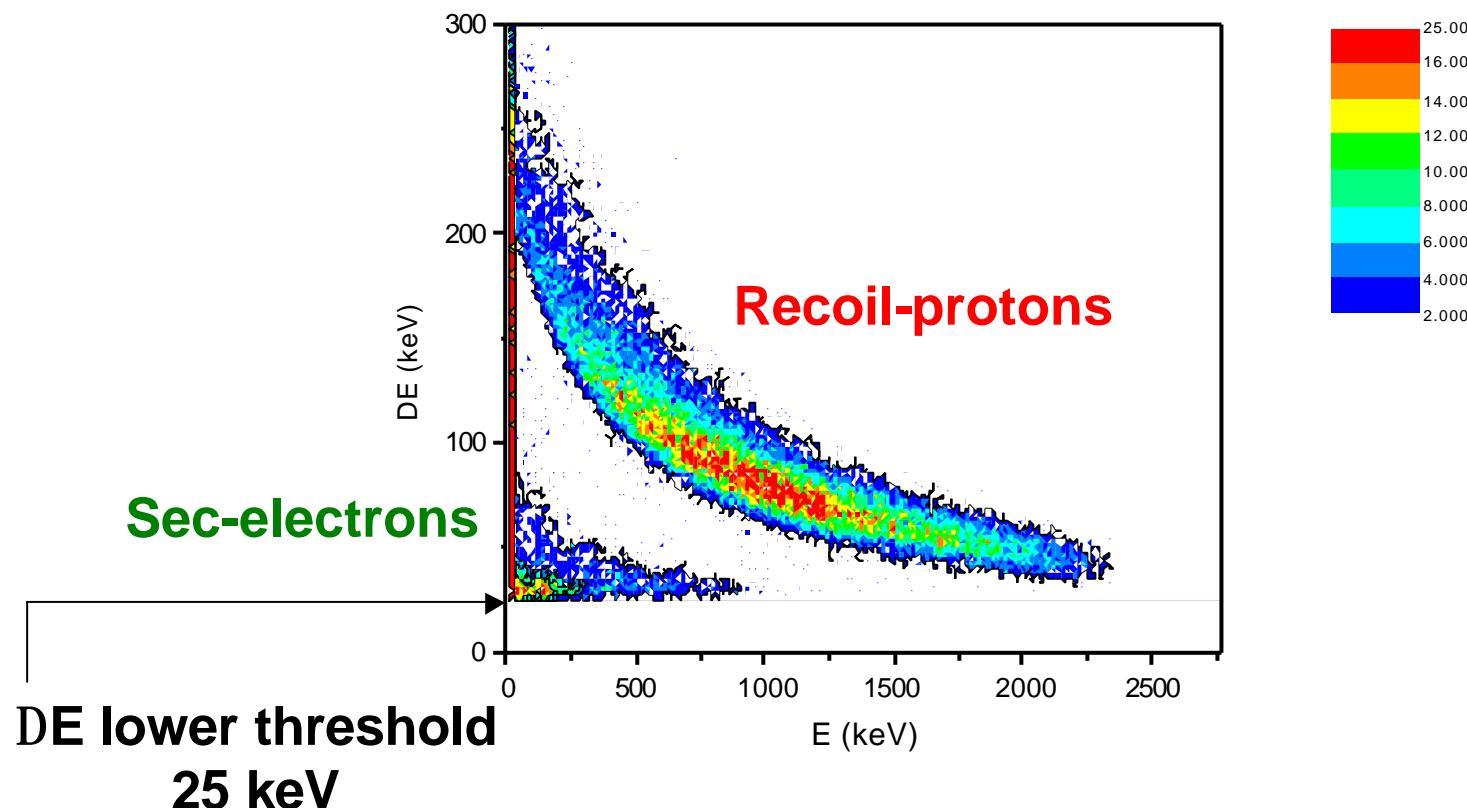
# E response



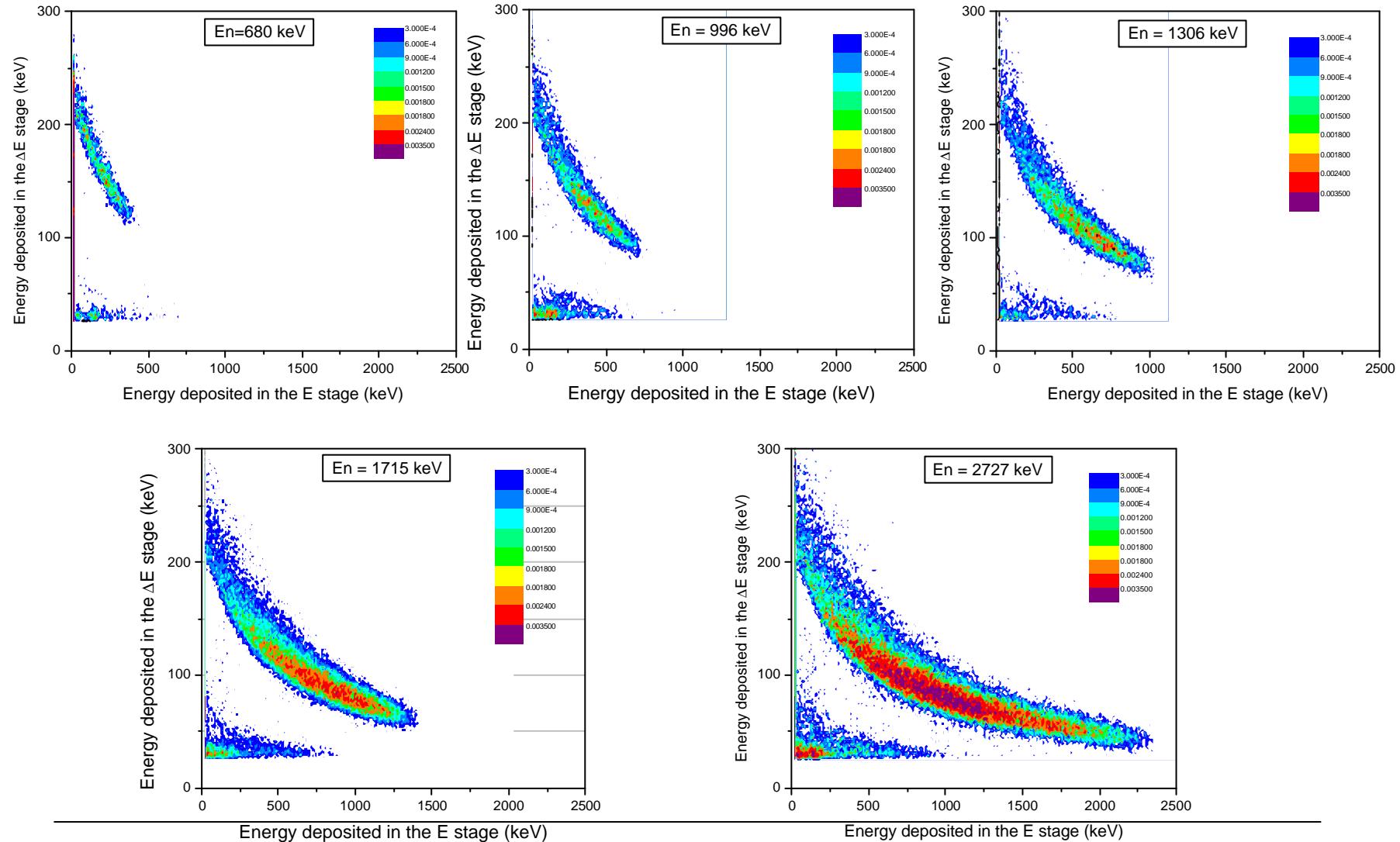
The E stage is in coincidence with the  $\Delta E$  stage

# DE-E scatter plot of recoil protons in strong g- field

Irradiations at Van de Graaff CN accelerator of INFN Legnaro Labs.  
Monoenergetic neutrons at 2727 keV

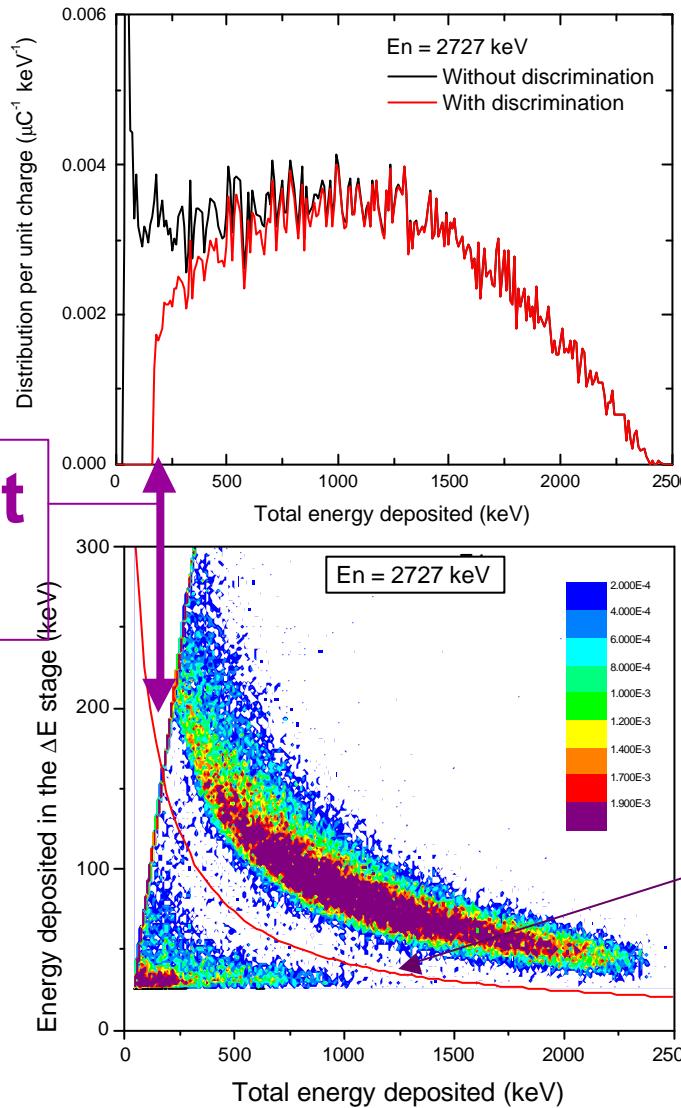


# DE-E scatter plots of the response function

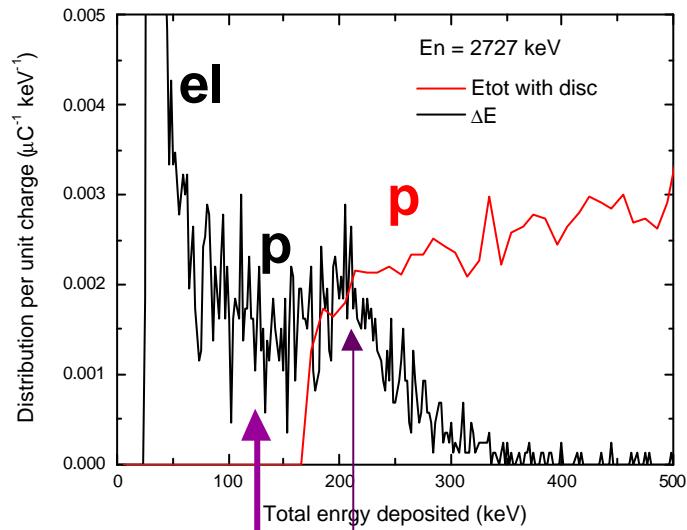


# Total energy spectrum with electron discrimination

Low energy limit  
~160 keV

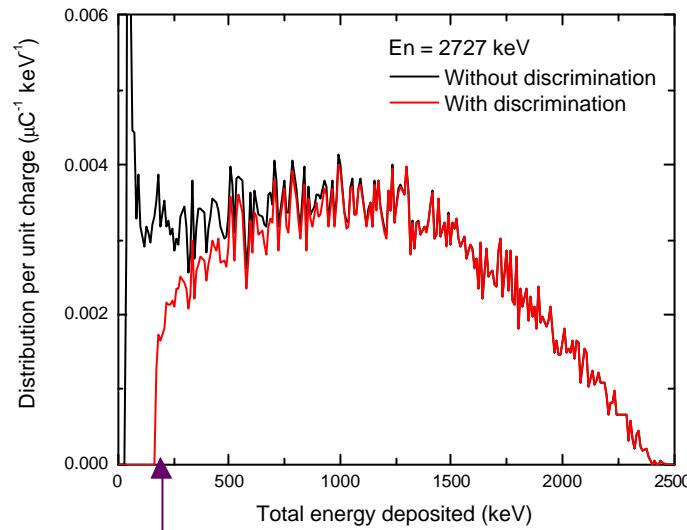


# Stopper analysis



**connection  
~210 keV**

**Low-energy limit ~130 keV**



**cutting line**

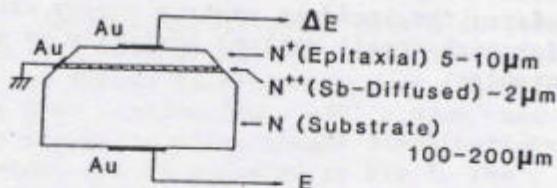


Fig.1-(a) Cross sectional view of the epitaxial integrated dE-E detector.

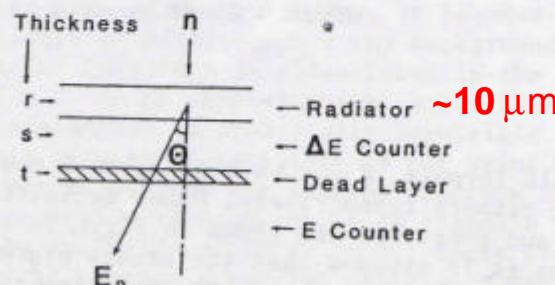


Fig.1-(b) Recoil proton spectrometer for fast neutron detection. E : Recoil proton energy.  $\theta$  : The recoil angle.

F. Shiraishi, Y. Takami, H. Husimi, C. Kim, Y. Kim, K. Kikuchi, T. Sakai, "A new fast neutron spectrometer made of epitaxial integrated DE-E Si detector", IEEE Trans. Nucl. Sci. Vol.NS-32, No 1, Feb 1985, pp. 471-475

C. Kim, H. Kim, K. Kikuchi, K. Husimi, S. Ohkawa, Y. Fuochi, "Epitaxial integrated E – dE silicon detector with a buried low-resistive diffused layer", IEEE Trans. Nucl. Sci. Vol.NS-27, No 1, Feb 1980, pp. 258-265

**Thin** converter: small energy range  
Low precision @ low energy

Low efficiency @ high energy

$$E_n = E_p / \cos^2 \theta$$

$$r < R_p = 10 \mu\text{m} @ 600 \text{ keV}$$

$$= (E + \Delta E \cdot (r/2s + 1 + t/s)) \cdot \Delta E^2 / (s \cdot (dE/dx))^2 - (1)$$

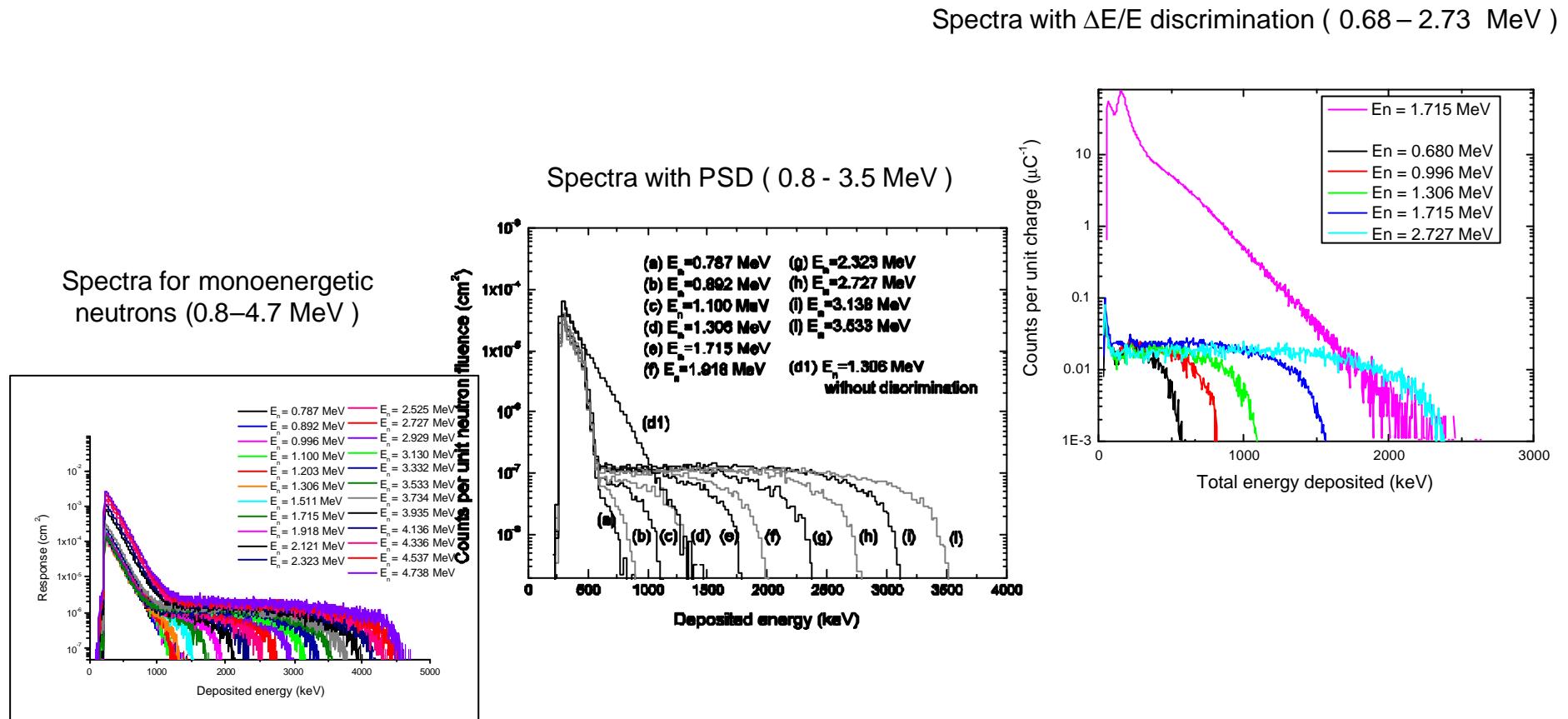
dE/dx : in dE counter



**Efficiency** [ $10^{-6} \text{ cm}^2$ ]  
for thick and thin converter  
(1 mm<sup>2</sup>, 1 Al dead layer, 700 μm Si)

	Thickness	En 5 MeV	En 10 MeV
Thick	$>R_p$	14	28
Thin	10 μm	1.1	0.67
Ratio		13	42

# Spectra for monoenergetic neutrons



# Conclusions

- The low-energy limit of a recoil-proton neutron spectrometer has been substantially improved
- Effective rejection of secondary electrons (in the strong g-field) has been obtained operating in coincidence with a second thin diode
- Further discrimination is based on electron identification on the DE-E scatter plot
- Monolithic DE-E structure allows to reach much lower discrimination threshold ( $< 150$  keV) with respect to PSD technique ( $\sim 600$  keV)